



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. .... 10/695,726  
Filing Date ..... October 28, 2003  
Inventor ..... Ross S. Dando et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1763  
Examiner ..... Karla A. Moore  
Attorney's Docket No. .... MI22-2432  
Customer No. .... 021567  
Title ..... Chemical Vapor Deposition Apparatus

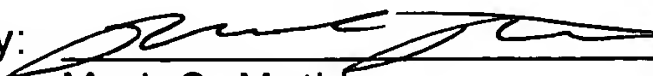
**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**  
References - See Attached Form PTO-1449


In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the reference listed on the attached Form PTO-1449, a copy of which is included herewith. No admission is made regarding whether the submitted reference as prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a Request for Continued Examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 2-28-07

By:   
Mark S. Matkin  
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2432		SERIAL NO.: 10/695,726		
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Ross S. Dando et al.				
				FILING DATE October 28, 2003		GROUP ART UNIT: 1763		
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM	U.S. Provisional Application No. 60/311,064, filed 08/08/01, naming Fangli Hao as inventor, and titled <i>Design for</i>						
		<i>Symmetrical Chamber Compensator With Two Degrees of Freedom Without Adding Actuator</i> , 8 pages.						
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								